

Docket No.: 5232-0102PUS1
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Hiroaki MATSUMURA et al.

Application No.: 10/563,811

Confirmation No.: 1910

Filed: June 9, 2006

Art Unit: 2828

For: NITRIDE SEMICONDUCTOR LASER
DEVICE AND LASER APPARATUS USING
THE SAME

Examiner: X. Niu

SUBMISSION UNDER 37 CFR 1.114

MS RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Madam:

INTRODUCTORY COMMENTS

In response to the Final Office Action dated November 14, 2008, finally rejecting claims 1, 2, 4-16 and 18-22, the period for responding being extended by two (2) months, through April 14, 2009, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper; and

Remarks/Arguments begin on page 10 of this paper.